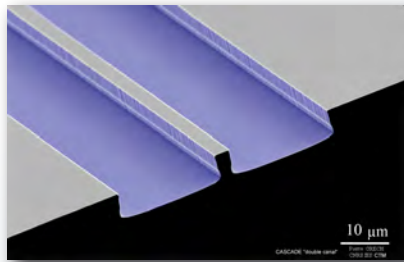
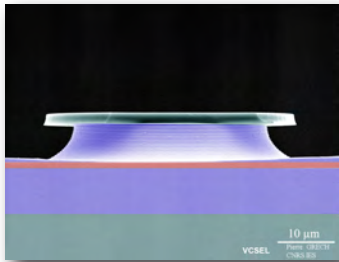
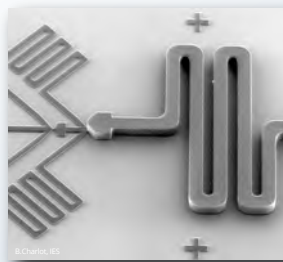


Exemples de réalisations

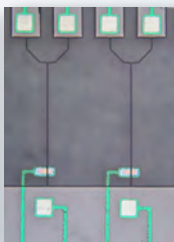
Lasers à semiconducteurs III-V



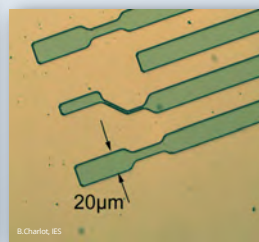
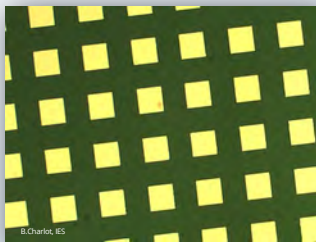
Microfluidique (SU-8)



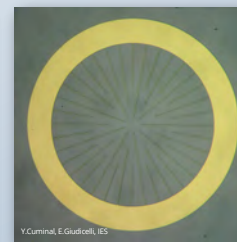
Réseau d'électrodes en microfluidique



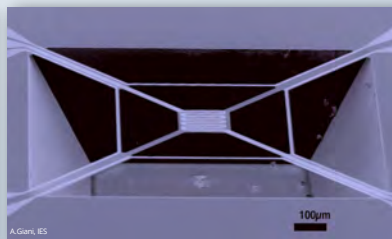
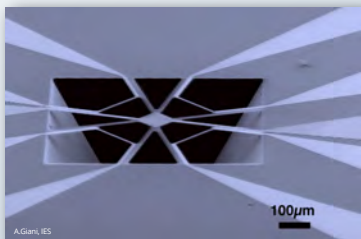
Polymères conducteurs (PEDOT:PSS)



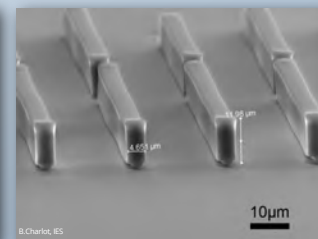
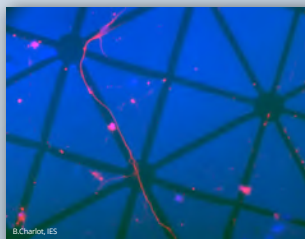
Cellule PV



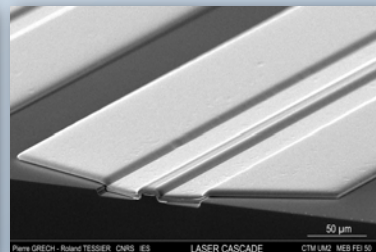
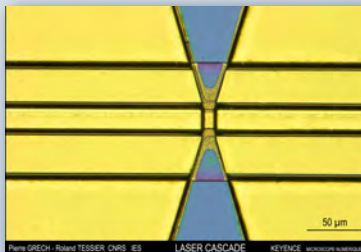
Accéléromètres MEMS (Micro usinage en volume)



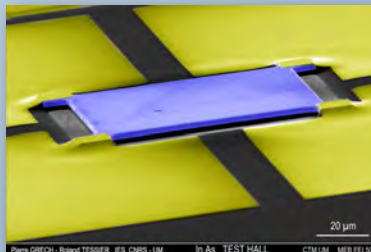
Lithographie douce et stamping



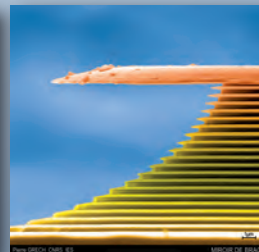
Laser Cascade



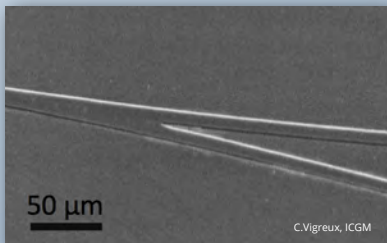
Effet Hall



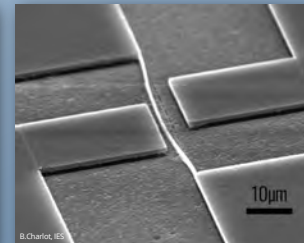
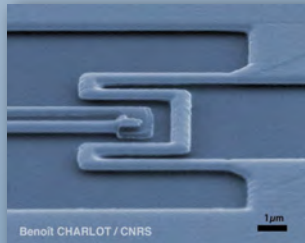
Miroir de Bragg



Guides d'onde infrarouge



Lithographie électronique



Centrale de Technologie
en Micro et nanoélectronique

